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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the application of:

Attorney Docket No.: 3339.12US02

Hidetoshi Juryozawa et al.

Confirmation No.: 8491

Application No.: 10/760,056

Examiner: Daniel Sean Larkin

Filed: January 16, 2004

Group Art Unit: 2856

For: VACUUM HEAT TREATMENT FURNACE AND METHOD OF AND APPARATUS
FOR MEASURING CARBON CONCENTRATION IN ATMOSPHERE HAVING
REDUCED PRESSURE

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action of November 1, 2004, and in accordance with the automatic extension of time for response provided by 37 C.F.R. § 1.136(a), amendment to the above-identified patent application is requested.

The present amendment comprises the following sections:

- A. Amendments to the Specification
- B. Amendments to the Claims
- C. Amendments to the Drawings
- D. Remarks

Please grant any extension of time necessary for entry; charge any fee due to Deposit Account No. 16-0631.

CERTIFICATE OF MAILING

I hereby certify that this document is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

March 1, 2005
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James H. Patterson